

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Christof Baur, et al.

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Group Art Unit: Unknown

Serial No. 10/684,120

§ 8

Filed: October 10, 2003

Examiner: Unknown

For: SYSTEM AND METHOD FOR PICKING AND PLACING OF NANOSCALE OBJECTS UTILIZING DIFFERENCES IN CHEMICAL AND

§ 8

PHYSICAL BINDING FORCES

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any fees which may be required Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

Priscilla L. Ferguson

Registration No. 42,531

Date: January 27 2004
HAYNES AND BOONE, LLP

901 Main Street, Suite 3100 Dallas, Texas 75202-3789 Telephone: 214-651-566p2 Facsimile: 214-200-0853

File: 34003.55 D-1203907.1 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on January 27, 2004

Signature of person mailing paper

U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE Complete if Known Application Number: 10/684,120 **INFORMATION DISCLOSURE** Filing Date October 10, 2003 Applicant(s) Christof Baur, et al. STATEMENT BY APPLICANT Art Unit (use as many sheets as necessary) Unknown Examiner Name 🖑 🦂 Unknown 34003.55 SHEET OF Attorney Docket Number

OTHER PRIOR ART							
Examiner's	1000 at 500 at 500	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-					
Initials	No.	issue number(s), publisher, city/country where published					
	AA	C. BAUR, A. BUGACOV, B.E. KOEL, A. MADHUKAR, N. MONTOYA, T.R. RAMACHANDRAN, A.A.R.					
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Examiner		Date	
Signature		Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

D-1203842.1